

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/653,149  
Filing Date ..... August 31, 2000  
Inventor ..... Garo J. Derderian, et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2818  
Examiner ..... T. Lee  
Attorney's Docket No. .... MI22-1330  
Title: Capacitor Fabrication Methods and Capacitor

*2<sup>nd</sup> Suppl.  
I.I.D.S.  
C. Stanley  
11-12-02*

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

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PATENT & TRADEMARK OFFICE  
WASHINGTON, D.C.

References - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of the Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37

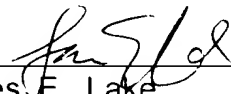
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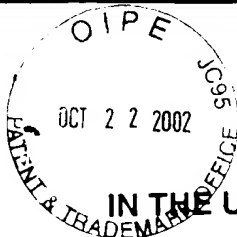
C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 22 Oct 2012

By:   
James E. Lake  
Reg. No. 44,854



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EV077331658US

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Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**COPY FOR YOUR INFORMATION**

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: 01 Jul 2002

By: \_\_\_\_\_

James E. Lake  
Reg. No. 44,854



COPY FOR YOUR INFORMATION

Inventor: Garo J. Derderian, et al  
Assignee: Micron Technology, Inc.  
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Constructions

**INFORMATION DISCLOSURE STATEMENT**

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Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 08 Oct 2001

Attorney: \_\_\_\_\_

  
James E. Lake  
Reg. No. 44,854  
WELLS, ST. JOHN, ROBERTS,  
GREGORY & MATKIN P.S.  
601 W. First Ave., Suite 1300  
Spokane, WA 99201-3828  
(509) 624-4276

FI 844050648